

The AACVD of CFTS Family of Materials

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Abstract: Thin films based on earth abundant and non-toxic elements comprising Cu2FeSnS4 (CFTS), Cu2FeSnSe4 (CFTSe), Cu2(ZnyFe1-y) SnS4 (CZFTS), Cu2(ZnyFe1-y) Sn (SxSe1-x)4 (CZFTSSe) have been deposited by Aerosol Assisted Chemical Vapour Deposition (AACVD) from mixtures of molecular precursors. These materials are highly important for optoelectronic and solar energy applications. The structure, morphology, composition, optical and electrical properties of the deposited materials were investigated.

Keywords: CZTS, CFTS, AACVD, XRD, SEM

1. INTRODUCTION

Copper zinc tin sulfide (CZTS) and coper iron tin sulfide materials important absorber materials for solar cells. These materials are made from nontoxic, low cost and earth abundant elements. CZTS has a band gap of ~ 1.45 eV suitable for the solar spectrum and has a high absorption coefficient > 10^4 . Solar cells with CZTS have already demonstrated power conversion efficiency of ~9.2 %.¹ There are few studies reported for materials that can form in both the kesteritic (space group I⁴8m) and the stannitic (space group I⁴2m) type dependent upon the [Zn]:[Fe] ratio.² The addition of iron into CZTS thin films decreases the optical band gap which can improve the Power Conversion Efficiency (PCE) of Thin Film Solar Cells (TFSCs). The solubility of iron in the CZTS derivatives plays a key role in controlling many parameters.³

Many techniques including spray pyrolysis,⁴ sputtering,⁵ hybrid sputtering,⁶ sulfurization,⁷ photo chemical deposition,⁸ sol-gel sulferisation,⁹ pulsed laser deposition,¹⁰ thermal evaporation,¹¹ sol-gel spin coating¹² and spray pyrolysis have been used to deposit CZTS thin films.¹³ A solution based synthesis of CFTS was reported recently using metal salts and sulfur in hot oleylamine to produce the Stannite phase of CFTS nanocrystals with particles of diameter between 15–25 nm.¹⁴ Jiang *et al* reported a non-aqueous strategy for the synthesis of hierarchical porous quaternary chalcogenide Cu₂FeSnS₄ as hollow chain microspheres by a microwave method using CuCl₂, FeCl₃, SnCl₄ and thiourea in benzyl alcohol and octadecylamine.¹⁵ Recently Guan *et al.* synthesized flower like CFTS nanoparticles by a microwave method using Fe(NO₃)₃, SnCl₂, Cu(NO₃)₂ and thiourea in ethylene glycol.¹⁶ The structure of Cu_{2-x} Fe_{1-x} SnS₄ was investigated by the Reitveld method by Evastigneeva *et al.*¹⁷ Zhang *et al.* have reported the phase controlled synthesis of wurtzitic CFTS nanoparticles with a band gap of 1.50 eV.¹⁸ The performance of a photovoltaic cells can be further improved by controlling the composition of the material and by the incorporation of extrinsic impurities such as Fe or Se in place of Zn and S respectively *e.g.* as in CZTS.^{19,20} Varying the Fe: Zn in CFTS and S:Se ratio in CZTS can tune both the band gap and lattice parameter.¹⁸⁻²²

Herein we report the thin films deposition of this multinary family of materials by AACVD and the investigation of different parameters affecting the phase, morphology, band gap and electrical resistance of these materials.

2. EXPERIMENTAL

2.1. Synthesis of Precursors

The compounds $[Cu (S_2CNEt_2)_2]$ (1), $[Fe (S_2CNEt_2)_3]$ 2), $[{}^{n}Bu_2Sn(S_2CNEt_2)_2]$ (3) and $[Zn(S_2CNEt_2)_2]$ (4) were synthesised and recrystallized as described in literature.¹

 $[Zn(Se_2CNEt)_2]$ and $[Cu(Se_2PPh_2)_2N]$ were prepared as reported in literature.²³

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2.2. Deposition of Thin Films

The thin films were deposited using AACVD. Glass slides (1 x 2 cm) were used as substrates for the deposition of thin films. Substrates were thoroughly cleaned and sonicated in acetone for 30 minutes to remove any possible contamination. In a typical deposition experiment, precursor complex (or a suitable combination of precursors) was dissolved in 20 mL THF taken in a two-necked 100 mL round-bottom flask. The round-bottom flask was kept in a water bath above the piezoelectric modulator of a PIFCO ultrasonic humidifier (model 1077). The aerosol droplets of the precursor thus generated were transferred into the hot wall zone of the reactor by a carrier gas (Argon). The Argon flow rate was controlled at 180 sccm by a Platon flow gauge. Both the solvent and precursor were evaporated, and the precursor vapor reached the heated substrate surface where thin film was deposited at 300- 450 °C.

2.3. Deposition of CFTS/Se Thin films

In a typical deposition of CFTS [Cu(S₂CNEt₂)₂] (2.80 mmol), [Fe(S₂CNEt₂)₃] (1.40 mmol), and [Bu₂Sn(S₂CNEt₂)₂] (1.40 mmol) were mixed in 20 mL of THF in a two neck flask under argon (200 *sccm*). Depositions were carried out at 300, 350 and 400 °C on glass substrates for 50 minutes. For CFTSe or CFTSSe different ratios of [Cu(Se₂PPh₂)₂N] were used.

2.4. Deposition of CZFTS/Se Thin Films

Thin films of $Cu_2(Zn_yFe_{1-y})SnS_4$ (CZFTS) were deposited using a mixture of $[Cu(S_2CNEt_2)_2]$ (2.78 mmol), $[Fe(S_2CNEt_2)_3]$ (0.7 mmol), $[Zn(S_2CNEt_2)_2]$ (0.7 mmol) and $[^nBu_2Sn(S_2CN Et_2)_2]$ (1.40 mmol) in the molar ratio 2: 1: 0.5: 0.5: 1 in 20 ml THF. The AACVD experiments were carried out as described above at 300 and 350 °C. The Fe-rich compositions of this material were deposited by increasing the ratio of the iron precursor as compared to that of zinc precursor. A mixture of $[Cu(S_2CNEt_2)_2]$ (2.78 mmol), $[Fe(S_2CNEt_2)_3]$ 1.0 mmol), $[Zn(S_2CN Et_2)_2]$ (0.4 mmol) and $[^nBu_2Sn(S_2CNEt_2)_2]$ (1.40 mmol) in 2 : 1 : 0.7 : 0.3 : 1 molar ratio in 20 ml THF was used to deposit films at 350 °C. For CZFTSe and CZFTSSe thin films $[Zn(Se_2CNEt_2)_2]$ was used instead of $[Zn(S_2CNEt_2)_2]$.

2.5. Characterization of Thin Films

A Bruker AXS D8 diffractometer using Cu K α radiation with a step size of 0.05 degree over a range of 20 – 70 degree with a count rate of 10 s we used for p-XRD studies. Thin films were mounted flat on non-reflective steel surface and scanned accordingly. Microstructure of the films was studied using Philips XL30 FEG SEM and EDX measurements were carried out using DX4 instrument. Raman spectroscopic measurements taken in Renishaw 1000 micro Raman system includes diode Laser at 514 nm and 50 mW power. UV-Vis spectra measurements taken from UV-VIS NIR Perkin Elmer 1050 Spectrometer. Electrical sheet resistance had been measured using Jandel four probe conductivity meter with 1 μ A current at room temperature.

3. RESULTS AND DISCUSSION

3.1. Thermal Gravimetric Analysis

Thermal decomposition studies were carried at 10-600 °C; heating rate 10 °C min⁻¹ under nitrogen. All compounds show rapid single step decomposition between 250-350 °C. The residual mass of $[Fe(S_2CNEt_2)_3]$ complex found to be about 18% which is close to the calculated percentage of FeS (17.5%). The $[Bu_2Sn(S_2CNEt_2)_2]$ complex decomposed slightly faster than the other complexes and the residual mass was found to be ~ 34 % which agrees with the calculated residual mass of SnS₂. $[Zn(S_2CNEt_2)_2]$ and $[Zn(Se_2CNEt_2)_2]$ resulted with ~9-10 % residue which found to be half or less than half of the mass of the expected metal chalcogenides; ZnS (27 %) and ZnSe (20 %) which may be due to sublimation of the complex.

3.2. CFTS Thin Films

Deposition of CFTS at all the temperatures produced, thin black, adherent specular films. p- XRD patterns of all these films correspond to the stannite phase of CFTS (ICDD 00-026-0532), cubic crystal system with a space group I-43m. The main peaks appeared at 20 values of 28.8, 33.0, 33.6, 47.3, 47.6, 57.0, 70.5, 78.4 (Figure 1). The p-XRD pattern of the films deposited at 350 °C showed a

match with the Stannite phase (Figure 1) whereas those deposited at 300 and 400 $^{\circ}$ C were slightly shifted (Figure 1 (b)) due to being tin rich or iron rich stoichiometry.

The morphology of the films deposited at the three different temperatures is shown in Figure 2. The SEM images of those deposited at 300 °C consist of irregular flakes of 1- 2 μ m which changes to thicker hexagonal plates at 350 °C, with about the same size, further change to irregularly shaped smaller crystallites ~ 0.5–1 μ m occurs at 400 °C.

The EDX for films deposited at 350 °C gave the stoichiometric ratio Cu (27.9%), Fe (13.89%), Sn (15.28%), S (42.90%) corresponding to Cu_{2.0}Fe_{1.0} Sn_{1.2}S_{3.5}, whereas those deposited at 300 °C were Fe rich and Sn deficient: Cu (32.83%), Fe (14.25%), Sn (5.57%), S(50.45%), Cu_{2.2}Fe_{1.0} Sn_{0.4}S_{3.9}, deposits at 400 °C were Cu rich with composition: Cu (26.28%), Fe (12.23%), Sn(21.98%), S(39.50%), Cu_{2.1}Fe_{1.0} Sn_{1.8}S_{3.2}. The EDX analysis confirmed the slight shift in p-XRD patterns due to the small variation in the composition of the Cu₂FeSnS₄ films. Raman spectra showed weaker peaks at 218, 285 cm⁻¹ and a strong peak at 321 cm⁻¹ which agree with the reported values for CFTS (Figure 3).²⁴ No peaks were observed at 282 cm⁻¹ (FeS), or 190 or 314 cm⁻¹ (SnS) confirming the phase purity of CFTS.²⁵ Band gap measurements of the films deposited at 350 °C and 400 °C gave values between 1.45 - 1.50 eV which are close to those reported previously (Figure 5d). The sheet resistance measurement of the films deposited at 350 °C at room temperature were found to be 2.13 x 10 ³ Ω / cm² which is higher than that reported previously for the CZTS and CFTS materials.²⁶⁻²⁷



Figure1. (a) *p-XRD* patterns of films deposited at 300 °C, 350 °C and 400 °C respectively and (b) *p-XRD* patterns of CFTS films deposited at 350 °C. Peaks are indexed according to ICDD 00-026-0532 (standard stick patterns)



Figure2. (*a*)-(*c*) are SEM images of films deposited at 300, 350 and 400 °C respectively. (d) Raman spectra of films deposited at 300 °C, 350 °C and 400 °C

3.3. CZFTS Thin films

Thin films of $Cu_2(Zn_yFe_{1-y})SnS_4$ (CZFTS) were deposited using a mixture of $Cu(S_2CNEt_2)_2$ (2.78 mmol), [Fe(S₂CNEt₂)₃] (0.7 mmol), Zn(S₂CNEt₂)₂ (0.7 mmol) and [ⁿBu₂Sn(S₂CNEt₂)₂] (1.40 mmol) in 20 ml THF. At 300 °C dark green, very thin films were deposited which did not diffract whereas black adherent films were deposited at 350 °C. The p-XRD pattern of this correspond to the Kesteritic phase of $Cu_2(Zn_yFe)SnS_4$ (ICDD 01-083-2261) with tetragonal space group I-48m (Figure 3(a)). The SEM images showed the deposition of irregular flakes over the entire area of the substrate (Figure 6(a)). EDX results showed the deposition of the Zn-rich films: Cu (28.42%), Zn (8.84%), Fe (3.97 %), Sn (15.23 %), S (43.54 %) corresponding to $Cu_{2.2}Fe_{0.3}Zn_{0.7}Sn_{1.2}S_{3.4}$.



Figure3. (a) and (b) are the Fe rich and Zn rich CZFTS thin films deposited at 350 °C. Inset image shows the enlarged region of 2θ : 45 to 60°

The Fe-rich compositions of this material were deposited by increasing the ratio of the iron precursor as compared to that of zinc precursor in the mixture. A mixture of $[Cu(S_2CNEt_2)_2]$ (2.78 mmol), $[Fe(S_2CNEt_2)_3]$ (1.0 mmol), $[Zn(S_2CNEt_2)_2]$ (0.4 mmol) and $[^nBu_2Sn(S_2CNEt_2)_2]$ (1.40 mmol) in 20 ml THF was used to deposit films at 350 °C. The p-XRD pattern of as deposited films correspond to the Stannite phase of Cu₂ (ZnFe) SnS₄ (ICDD: 01-083-2262) with I-42m space group as shown in (Fig. 4(b)). SEM images showed a remarkable difference from the other films in morphology (Figure 5(b)), with uniform flakes. EDX results revealed the composition as (Cu (25.92%) Zn (4.52%) Fe (9.5 %) Sn (17.52 %) S (45.54 %)) giving an empirical formula of Cu_{1.9}Fe $_{0.6}Zn_{0.4}Sn_{1.3}S_{3.2}$.



Figure4. (a) and (b) SEM images and (c) Raman spectra of CZFTS Fe rich and Zn rich thin films deposited at $350 \text{ }^{\circ}\text{C}$

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Raman spectra showed peaks at ~340 cm⁻¹ and 350 cm⁻¹ for the A1 Raman vibration of sulfur atoms in the Kesteric and Stannic phases of the deposited CZTS films respectively. There was a slight variation in positions of peaks for the Zn-rich phase of the CZFTS, as reported previously (Figure 4(c)).²⁸ Band gap measurements for Zn-rich composition showed ~1.60 eV whereas those with Ferich composition gave a band gap of ~1.51 eV, as reported previously (Figure 5). Electrical resistance measured at room temperature were 2.48 KΩ/cm² for Fe-rich thin films and 2.98 2.48 KΩ/cm² for Znrich films. Variation in the electrical sheet resistance with different Fe-compositions has been studied. The electrical resistance measured at room temperature were 2.48 KΩ/cm² for Fe-rich thin films and 2.42 2.48 KΩ/cm² for Zn-rich films of CZFTS values which lie between the electrical sheet resistance for parent materials CZTS (2.8 2.48 KΩ/cm²) and CFTS (2.3 2.48 KΩ/cm²).^{29,30}



Figure5. (a)-(d) Tauc plots of CZTS and CFTS thin films depoisted at 350 and 400 °C. (e) and (f) are that of Fe-rich and Zn-rich phases of CZFTS thin films deposited at 350 °C

3.4. CFTSe Thin Films

The films were deposited at temperatures between 300 and 400 °C from different mixtures of precursors. The compositions of the films from EDX measurements in the electron microscope are summarized in Table 1. Iron incorporation is consistently close to the stoichiometric ratio calculated from the feed rate. In order to provide a consistent comparison of the films d spacings for each sample were also calculated from the principal peaks with the cubic indices. These are in good agreement for the known phases and the results of Rietveld refinements, all are summarized in Table 1. The CFTSSe thin films deposited using equimolar ratio of selenium and sulfur precursors at 300 and 350 °C gave thin black, adherent films. The p-XRD patterns of the CFTSSe showed clear shifts from that of CFTS. There seems to be a trace of an impurity in the film deposited at 300 °C and Rietveld analysis gave no matching with any of the known parent CFTS and CFTSe phases.

Table1. Consolidated p-XRD and EDX analalysis of CFTS, CFTSe and CFTSSe thin films deposited at different temperatures. \$ from peak position and $a^2 = d^2(h^2 + k^2 + l^2)$, & for cubic ICDD 00-53-0575 gives a = 5.4233 Å, + for cubic analysis ICDD 00-027-0167 gives a = 5.685 Å

| Film | Temp | Stoichiometry | Rietveldt | Cubic ^{\$} | Literature | Literature | (ICDD) [ref] |
|--------|------|---|-----------|---------------------|----------------------------|-------------|------------------|
| | °C | | a | а | а | с | |
| CFTS | 300 | Cu _{2.1} Fe _{0.92} Sn ₁ S _{3.3} | 5.4328(2) | 5.46(2) | 5.4495(6) ^{&} | 10.726(2) & | [20] |
| CFTS | 350 | $Cu_{1.8}Fe_{0.90}Sn_1S_{2.80}$ | 5.4261(6) | 5.45(1) | 5.4495(6) ^{&} | 10.726(2) & | [20] |
| CFTS | 400 | Cu _{1.2} Fe0.55Sn ₁ S _{1.8} | 5.414(4) | 5.402(1) | 5.4495(6) ^{&} | 10.726(2) & | [20] |
| CFTSSe | 300 | Cu _{1.2} Fe _{0.75} Sn1S _{0.14} Se _{3.4} | - | 5.487(7) | - | - | - |
| CFTSSe | 350 | $Cu_{1.8}Fe_{0.69}Sn_1S_{1.8}Se_{1.5}$ | - | 5.506(1) | - | - | - |
| CFTSSe | 400 | $Cu_{1.7}Fe_{0.56}Sn_1S_{1.8}Se_{1.02}$ | - | 5.510(5) | - | - | - |
| CFTSe | 350 | Cu _{2.74} Fe _{1.26} Sn ₁ Se _{5.9} | 5.714(0) | 5.663(3) | 5.7200+ | 11.286+ | 00-052-0098 [22] |
| CFTSe | 400 | $Cu_{1.0}Fe0{88}Sn_{1.0}Se_{2.26}$ | - | 5.64(6) | 5.7200^{+} | 11.286+ | 00-052-0098 [22] |

3.5. CZFTSe and CZFTSSe Thin Films

The deposition of Cu(ZnFe)SnSe₄ at 300 °C gave only amorphous material which did not show any diffraction by p-XRD whereas uniform dark brownish films were obtained at 350 °C. The p-XRD pattern of the thin films deposited at 350 °C show clear shifts from Zn-rich Cu₂ZnFeSnS₄ (ICDD: 00-83-0225) and Fe-rich Cu₂ZnFeSnS₄ (ICDD: 01-015-0228) phase as expected. The p-XRD pattern found to be broader because of the small particle size of individual crystallites and overlapping of peaks especially about 20: 47 to 48° and around 20: 55-56.

A similar deposition with more Fe precursor concentration at 350 °C gave thin brown films. The p-XRD patterns were analysed by comparing with the Zn-rich $Cu_2ZnFeSnS_4$ (ICDD: 00-83-0225) an Fe- rich $Cu_2ZnFeSnS_4$ (ICDD: 01-015-0228) phases, the p-XRD patterns were shifted significantly from the reference patterns. The p-XRD patterns were further analysed using $Cu_2FeSnSe_4$ patterns (JCPDS: 00- 027-0167) but none of the matching peaks were seen.

The deposition of $Cu_2(ZnFe)Sn(S_xSe_{1-x})_4$ using a mixture of precursors as described in the experimental part gave only a negligible amount of deposits at 300 °C whereas good quality black specular films were deposited at 350 °C. The p-XRD pattern of these films showed a clear shifts from those of the Fe-rich and Zn-rich phases of CZFTS indicating the formation of $Cu_2(Zn_yFe_{1-y})Sn(S_xSe_{1-x})_4$. The calculated lattice parameter a = 5.477 (5) Å. Another deposition with more Fe precursors at 350 °C produced thin black films. The p-XRD pattern was compared with Fe-rich ((ICDD: 01-015-0228) and Zn-rich ((ICDD 04-015-0225) CZFTS patterns. The peaks showed larger shift from both reference patterns. The lattice parameter a calculated from the p- XRD patterns was 5.429 (8) Å.

Elemental analysis of the films confirmed that the metal content of all films correlated well with mole fraction of metal in the feed shown in Figure 6. From the graph it shows a linear correlation between the mole fraction of Se in the precursor and in the deposited thin films.

SEM images with Fe-rich phases of C(ZF)TSe showed irregularly shaped crystallites with EDX analysis showing atomic percentage of Cu (26.13%), Zn (4.10 %), Fe (11.21 %), Sn (13.60%) and Se (44.13%) which gives a stoichiometric composition of Cu_{1.8}Zn_{0.3} Fe_{0.7}Sn_{0.9} Se_{3.0} corresponding to Fe-rich phase. The SEM images of Cu₂ (ZnFe)Sn(S_xSe_{1-x})₄ thin films deposited at 350 °C showed irregular plate like crystallites. The EDX analysis gave the atomic percentages as Cu (25.63%) Zn (8.74%) Fe (6.46%) Sn (12.46 %) S(28.74%) and Se (17.94 %) corresponding to Cu_{1.7}Fe $_{0.4}$ Zn_{0.6}Sn_{0.8}S_{1.9}Se_{1.2}, the Zn-rich and S-rich stoichiometry. The EDX analysis of the (ZnFe)Sn(S_xSe_{1-x})₄ films deposited at 350 °C with higher concentration of Fe showed Cu (26.87%) Zn (5.13 %) Fe (7.92%) Sn (11.15 %) S (26.24%) and Se (22.85 %) corresponding to Cu_{2.1}Fe $_{0.6}$ Zn_{0.4}Sn_{0.8}S_{2.1}Se_{1.7}.



Figure6. Correlation between mole fraction of each metal (x) in the feed and observed amount in the film by EDX

4. CONCLUSION

The materials $Cu_2(Zn_yFe_{1-y})SnS_4$ (CZFTS), $Cu_2(Zn_yFe_{1-y})SnSe_4$ (CZFTSe) and $Cu_2(Zn_yFe_{1-y})Sn(S_xSe_{1-x})_4$ (CZFTSSe) have useful band gaps, large absorption coefficient and transport properties suitable for PV applications. The band gaps of these materials lie between 1.1 eV and 1.7 eV which are ideal for absorber material in thin film solar cells. The ratios of the constituents: Zn and Fe and S and Se can be controlled by varying the concentrations of corresponding precursors and the deposition temperature to tune the band gap. In contrast to high-vacuum techniques, requiring specialised (and often expensive) equipment, AACVD is performed at ambient pressure and requires inexpensive apparatus. The fabrication of PV devices is underway to measure and compare the photovoltaic efficiency of these materials.

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